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PATENT
Attorney Docket No. MIT-166
(058420/157388)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Liu *et al.*
SERIAL NO.: 10/566,686 GROUP NO.: 1784
FILING DATE: March 8, 2007 EXAMINER: J. Langman
TITLE: METHOD AND STRUCTURE OF STRAIN CONTROL OF SIGE
 BASED PHOTODETECTORS AND MODULATORS

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This paper is responsive to the final Office action mailed on November 12, 2010, in the above-identified patent application.

Please consider following:

Remarks begin on page 2 of this paper.